

BOX 15

Docket No. 0756-935

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)	
Shunpei YAMAZAKI et al.)	
Serial No. 08/160,909)	Art Unit: 1107
Filed: December 3, 1993)	Examiner Wilczewski
For: METHOD OF FABRICATING)	
SEMICONDUCTOR DEVICES AND)	
APPARATUS FOR PROCESSING)	
A SEMICONDUCTOR)	June 21, 1996

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on June 21, 1996.

Deborah T. Tomme
Deborah T. Tomme

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

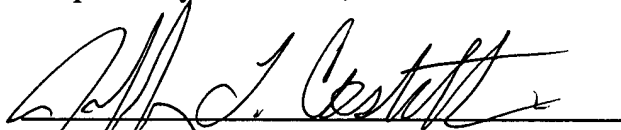
Transmitted herewith is an Amendment After Final Rejection, Petition for Two Month Extension of Time, Information Disclosure Statement, Form PTO-1449 and one cited reference and Petition to Accept Information Disclosure Statement After Final Rejection in the above-identified application.

The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Rate Sm/Lg Entity	Fee
Total	65	Minus	20	45	X 11/22	\$990.00
Indep.	10	Minus	3	7	X 39/78	\$546.00
First presentation of multiple dependent claims						-0-
TOTAL						\$1,536.00

- [X] A check in the amount of \$2,046.00 (\$1,536 additional claims fee; \$130 petition fee; \$380 extension fee) is enclosed.
- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-935).
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-935). A duplicate copy of this sheet is attached.

Respectfully submitted,



Jeffrey L. Costellia
Reg. No. 35,483

Sixbey, Friedman, Leedom & Ferguson, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110



990-203
546-202

RESPONSE UNDER 37 CFR 1.116 - EXPEDITED
PROCEDURE - EXAMINING GROUP 1107

#14CWE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

7-11-96
K. Speers

In re PATENT application of:)
Shunpei YAMAZAKI et al.) Ex. Wilczewski
Serial No. 08/160,909/) Art Unit No. 1107
Filed: December 3, 1993)
For: METHOD OF FABRICATING)
SEMICONDUCTOR DEVICES)
AND APPARATUS FOR PRO-)
CESSING A SEMICONDUCTOR) Docket No. 0756-935

19/D
9-17-96
M. Ross

AMENDMENT AFTER FINAL REJECTION

Honorable Assistant Commissioner for Patents
BOX AF
Washington, D.C. 20231

Sir:

In response to the final rejection Office Action mailed February 6, 1996, please amend the above identified application as follows.

IN THE CLAIMS:

Please amend claims 8, 12, 16 and 17 as follows:

8. (Twice Amended) An apparatus for processing a semiconductor provided on a substrate comprising:

D¹

CERTIFICATE OF MAILING
310 SD 06/28/96 08160909
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 6/27/96

Deborah J. Zomne D